Application/Control Number: 10/802,185

CLMPTO 01/10/05 CM.

CLAIMS 1-53. (CANCELLED)

CLAIMS 54-110. (CANCELLED)

- 111. (New) A semiconductor structure comprising:

  a substrate including an insulator layer; and
  a device layer disposed over the insulator layer, the device layer comprising at least one of strained Si, strained Si<sub>1-w</sub>Ge<sub>w</sub>, strained Ge, GaAs, AlAs, ZnSe, and InGaP.
- 112. (New) The structure of claim 111 wherein a surface of the structure has a root mean square surface roughness of less than about 11 nanometers.
- 113. (New) The structure of claim 111, further comprising:

  a device integrated into at least a portion of the device layer.
- 114. (New) The semiconductor structure of claim 111, wherein the substrate comprises silicon.
- 115. (New) A semiconductor structure comprising:

  a substrate comprising silicon;

  an insulating layer disposed over the substrate; and

  a relaxed Si<sub>1-y</sub>Ge<sub>y</sub> layer disposed over the insulating layer.

CLAIM 116. (CANCELLED)

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117. (New) The structure of claim 116 wherein the Ge concentration y has a value of 1.

118. (New) The structure of claim 115, further comprising:

a device disposed within at least a portion of the relaxed Si<sub>1-y</sub>Ge<sub>y</sub> layer.